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APPLICANTS Takashi Ozaki, Tokyo, JAPAN; Tomoshi Taniyama, Tokyo, JAPAN; Hiroshi Unami, Tokyo, JAPAN; Kiyohiko Maeda, Tokyo, JAPAN; Shinya Morita, Tokyo, JAPAN; Yoshikazu Takashima, Tokyo, JAPAN; Sadao Hisakado, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/01996 02/20/2004				
** FOREIGN APPLICATIONS ***** JAPAN 2003-44049 02/21/2003 JAPAN 2003-44904 02/21/2003 JAPAN 2003-87966 03/27/2003 JAPAN 2003-87884 03/27/2003				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 20
		INDEPENDENT CLAIMS 6		
ADDRESS 23850				
TITLE Substrate-processing apparatus and method of producing a semiconductor device				
FILING FEE RECEIVED 1630	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	